LISTING OF THE CLAIMS

- 1-5. (Canceled).
- 6. (Currently amended) A heat control apparatus for a circuit, comprising:
- a transparent cooling mechanism tightly secured to a semiconductor integrated circuit, the transparent cooling mechanism having a hollow part;
- an image capturing sensor which captures an image of the semiconductor integrated circuit through the cooling mechanism;
- a heat detecting unit which acquires the heat generation condition of the semiconductor integrated circuit from an inspection image captured by the sensor; and
 - an analyzing unit which analyzes the acquired heat generation condition; and
- a driving mechanism for causing a coolant to flow in the hollow part of the transparent cooling mechanism, wherein the hollow part is provided so as not to overlap the semiconductor integrated circuit.
- 7. (Original) The heat control apparatus for a circuit according to claim 6, wherein the cooling mechanism is a silicon heat spreader and comprises a cooling means for cooling the heat spreader.
 - 8-11. (Canceled).
- 12. (Currently amended) The heat control apparatus for a circuit according to claim $9\underline{6}$, wherein the driving mechanism changes the direction of flow of the coolant as appropriate.
- 13. (Original) The heat control apparatus for a circuit according to claim 12, wherein the analyzing unit synthetically analyzes heat generation conditions detected prior to and subsequent to a change in the direction of flow of the coolant.

14. (Currently amended) The heat control apparatus for a circuit according to claim $9\underline{6}$, wherein the analyzing unit analyzes the heat generation condition by taking into account temperature gradient dependent on the direction of flow of the coolant.

15-18. (Canceled).

- 19. (New) The heat control apparatus for a circuit according to claim 6, wherein the heat detecting unit acquires the temperature distribution of the semiconductor integrated circuit from the inspection image, and if the temperature exceeds a predetermined threshold value at any location in the semiconductor integrated circuit, the cooling control unit enhances the cooling capability of the cooling means.
- 20. (New) The heat control apparatus for a circuit according to claim 6, further comprising: an operation control unit for controlling the operating condition of the semiconductor integrated circuit in accordance with the acquired heat generation condition.
- 21. (New) The heat control apparatus for a circuit according to claim 20, wherein the heat detecting unit acquires the temperature distribution of the semiconductor integrated circuit from the inspection image, and if the temperature exceeds a predetermined threshold value at any location in the semiconductor integrated circuit, the operation control unit reduces a load per unit time in the location where the temperature exceeds the threshold value.